# Application Brief Highly Scalable TI DLP Technology for 3D Machine Vision

# TEXAS INSTRUMENTS

## **3D Machine Vision**

3D machine vision is a fast and accurate optical technique used to capture physical details of an object. With the digitized 3D scan data, the dimensions of any object including; surface area, volume, and feature size can be extracted. Structured light is a method of 3D scanning where a series of patterns are projected upon an object and a camera or sensor detects distortions of the patterns. Image processing and triangulation algorithms then convert these distortions into a 3D point cloud. The point cloud can be used directly for analysis of the object or easily exported to a variety of CAD modeling formats.

TI DLP technology enables programmable structured light solutions for portable and high resolution applications. DLP systems can produce non-contact, highly accurate 3D data in real-time, facilitating 3D machine vision.

#### **Features and Benefits**

#### • Fast, programmable pattern rates up to 32 kHz

- Acquire 3D scan data in real-time on moving objects.
- Optimize scan speed and accuracy for multiple objects and environments using adaptive pattern sets.
- Precise depth capture
  - Achieve measurement accuracy to sub µm level.
- Digital switching using reflective, reliable MEMS micromirrors
  - Consistent performance over time and temperature with minimal sensitivity to color and environment.
- Active illumination with LEDs, lasers, or lamps
  - Multiple wavelengths for scanning a wide range of materials.
  - Enables strong low light performance.

# **DLP Solutions for 3D Machine Vision**

DLP chipsets are available with different DMD (Digital Micromirror Device) sizes, pixel pitches, resolutions, and wavelength capabilities. The best choice for a DLP chipset can depend on the size of the scanning volume, pattern speed and system form factor. The table at the end of this document includes chipset offerings varying in resolution, speed and size. Higher resolution DMDs allow for a larger point cloud. High speed DMDs increase throughput with faster pattern speeds. Smaller DMDs allow for small form factor solutions.

#### **Example Applications**

- Factory automation
- Industrial robotics
- Medical imaging
- Dental scanning / intraoral scanning (IOS)
- Industrial metrology
- Biometrics



#### Figure 1. 3D Scanner Mounted on Robotic Arm

# **Evaluation Modules**

Accelerate your design cycle by evaluating DLP technology with a broad selection of evaluation modules (EVMs). Our portfolio of EVMs offer a compelling combination of resolution, brightness, pattern speed, and programmability of DLP technology.

TI provides free software and firmware downloads allowing developers to easily create, store, and display high-speed pattern sequences through USBbased application programming interface (API) and easy-to-use graphical user interface (GUI).

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**Reference Designs and Ecosystem Support** 

block diagrams, bills of materials, design files,

and Optical Module Maker Search Tool.

to full 3D scanner designs.

There are several reference designs and third party

modules to empower developers with a framework to build accurate 3D scanners and 3D machine vision systems. Reference designs include schematics,

software, and test reports. The reference designs and

third party modules range from projection subsystems

To learn more, visit Advanced Light Control Reference

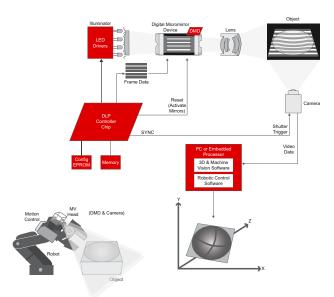
Designs, Explore Our Third-Party Solution Providers,

# To find an EVM, visit:

- High-Speed Visible: Design and Development
- Near-Infrared: Design and Development

#### System Block Diagram

The DLP solution for 3D machine vision is shown in the diagram. DLP technology enables 3D machine vision capabilities by providing single or multiple camera 3D image capture. The system utilizes a DMD as a spatial light modulator and a DMD controller to provide high-speed control of the micromirrors. TI LED drivers provide illumination for the DMD to project the image. From power management to embedded processors to support the system, TI's vast portfolio provides a complete system solution to create your ideal 3D machine vision design.



#### Figure 2. System Block Diagram

#### Table 1. DLP Chipsets for 3D Machine Vision

Digital Micromirror Device (DMD)	Micromirror Array Size	# of Pixels (MP)	# of Prestored Patterns			Max Pattern Rate (Prestored Patterns) (Hz)			Controller Part Number	Evaluation Module
			1-bit	8-bit	16-bit	1-bit	8-bit	16-bit		
DLP2010NIR	854 × 480	0.41	64*	8*		2487	272		DLPC3470	
DLP2010LC	854 × 480	0.41	64*	8*		2487	272		DLPC3470	DLP2010EVM-LC
DLP3010LC	1280 × 720	0.92	51-64*	6-8*		2487	272		DLPC3478	DLP3010EVM-LC
DLP4500	912 × 1140	1.04	48	6		4225	120		DLPC350	DLPLCR4500EVM
DLP4710LC	1920 × 1080	2.07	60-64*	7-8*		2500	437		DLPC3479× 2	DLP4710EVM-LC
DLP5500	1024 × 768	0.79	960	120		5000	500		DLPC200	
DLP6500	1920 × 1080	2.07	400	50		11574	1446		DLPC900	DLPLCR65EVM
DLP7000	1024 × 768	0.79		N/A		32552	4069	2034	DLPC410	DLPLCR70EVM
DLP500YX	2048 × 1200	2.46	800	100	50	16100	2016	1008	DLPC900× 2	DLPLCR50XEVM
DLP670S	2716 × 1600	4.35	400	50		9523	1190		DLPC900× 2	DLPLCR67EVM

\* Prestored patterns are column-repeat or row-repeat (1D) patterns

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